



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki, et al.

Serial No. : 09/966,689

Filed : September 27, 2001

Title : DRY ETCHING APPARATUS, ETCHING METHOD AND METHOD OF  
FORMING A WIRING

Art Unit : 1765

Examiner : Kin-Chan Chen

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**AMENDMENT IN REPLY TO ACTION OF MARCH 25, 2004**

Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of the claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.